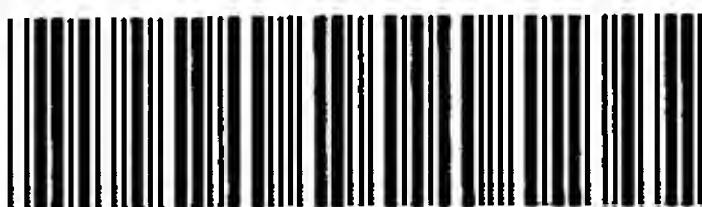


Search Notes



Application/Control No.

10/604.641

Examiner

José V. Chen

**Applicant(s)/Patent under
Reexamination**

PONZIO, MASSIMO

Art Unit

3637

SEARCHED

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)